

Group Art Unit: 2886
Confirmation No.: 3799
Examiner: Nur, A.

Atty. Ref.: F04-018US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tohru Koike et al.
Appl. No. : 10/575,714
Filed : May 8, 2006
For : METHOD FOR MEASURING A SURFACE PLASMON
RESONANCE AND NOBLE METAL COMPOUND USED FOR THE
SAME

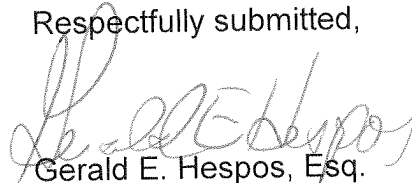
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENT TO THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

This communication supplements the Information Disclosure Statement filed on January 11, 2010. That Information Disclosure Statement included a copy of the Japanese Office Action. Counsel now has received an English language translation of the Japanese Office Action. That translation is attached to this Information Disclosure Statement and may help the Examiner's understanding of the reference cited in the Japanese Office Action.

Respectfully submitted,



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Date: January 12, 2010